

LAW OFFICES OF
WU & CHEUNG, L.L.P.7700 IRVINE CENTER DRIVE, SUITE 710
IRVINE, CALIFORNIA 92618 - 3043 U.S.A.

TELEPHONE: (949) 251 - 0111

FACSIMILE: (949) 251 - 1588

E-MAIL: INFO@WCLAWYERS.COM

WWW.WCLAWYERS.COM

RECEIVED
CENTRAL FAX CENTER
OCT 21 2003

OFFICIAL

FACSIMILE COVER PAGE

OCTOBER 21, 2003			
TO:	UNITED STATES PATENT AND TRADEMARK OFFICE GROUP ART UNIT:2813		
FAX NO.:	703-872-9318		
COMPANY:	N/A		
OUR FILE NO.:	JC-7109-CIP		
CLIENT NAME:	JCIPO		
TOT. PAGES:	6	SENT BY:	JM
ORIGINAL WILL FOLLOW VIA U.S. MAIL: <input type="checkbox"/> YES <input checked="" type="checkbox"/> NO			

The information contained in this transmission is privileged and confidential. It is intended only for the use of the individual or entity named above. If the reader of this message is not the intended recipient, you are hereby notified that any dissemination, distribution or copying of this communication is strictly prohibited. If you have received this communication in error, please notify us immediately by telephone collect and return the original message to us at the address above via the U.S. Postal Service. We will reimburse you for your postage.

SUBJECT: PRELIMINARY AMENDMENT**Re: U.S. Patent Application**

Title : POST-CMP REMOVAL OF SURFACE CONTAMINANTS
FROM SILICON WAFER
Attorney Docket No. : JC-7109-CIP
Filing Date : JUNE 24, 2003
Serial No. : 10/603,924

MESSAGE:

Please acknowledge receipt of this Preliminary Amendment via fax confirmation to (949) 251-1588.



Creation date: 10-28-2003
Indexing Officer: JFLORES - JAIME FLORES
Team: OIPEBackFileIndexing
Dossier: 10060922

Legal Date: 10-17-2003

No.	Docode	Number of pages
1	DIST	3
2	LET.	2
3	IMIS	1

Total number of pages: 6

Remarks:

Order of re-scan issued on